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Jun-Seok Oh was born in Seoul, Korea, in 1974. He received the B.Sc. and M.Sc. degrees from Kwangwoon University, Seoul, Korea, in 2001 and 2003, respectively, and the Ph.D. degree from Kyoto University, Kyoto, Japan, in 2006. In 2003, he joined the International Doctoral Program in engineering at Kyoto University and awarded Monbukagakusho Scholarship (Japanese Government) during the program for three years. Then, he held a few postdoctoral positions: Japan Science and Technology Agency (JST), Tohoku University, and the University of Liverpool. In 2013, he became an Assistant Professor with the School of Systems Engineering, Kochi University of Technology. In 2016, he joined Meijo University as a Senior Researcher and moved to Graduate School of Engineering, Osaka City University, as an Associate Professor, since 2018. His current research interests include the development of new plasma technologies based on optical and electrical plasma diagnostic techniques. Recently, he became interested in plasma biomedical applications based on atmospheric pressure plasma technology as well as traditional plasma deposition process with vacuum technology. He is a member of the Japan Society of Applied Physics (JSAP), the Japan Society of Plasma Science and Nuclear Fusion Research (JSPF), the Materials Research Society of Japan (MRS-J), and the Institute of Physics (IOP), U.K.